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LIST OF REFERENCES CITED BY APPLICANT				Jean DIJON, et al.			
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				August 8, 2006	<u>, </u>		
	,			U.S. PATENT DOCUMENTS			
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
MLP/	AA	2003 0234417	12-25-03	RAAIJMAKERS, Ivo et al.	200000000000000000000000000000000000000	A0000000000000000000000000000000000000	
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
/M.L.P./	AV	YUDASAKA, Masako et al.," Specific Conditions for Ni Catalyzed Carbon Nanotube Growth by Chemical Vapor Deposition", Applied Physics Letters, Vol. 67, No. 17, pgs. 2477-2479, 1995. October					
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Examiner	/Marianne Padgett		Date Considered 10/14/2009				
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in							
conformance and not considered. Include copy of this form with next communication to applicant.							